



UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D. C. 20231
www.uspto.gov



Bib Data Sheet

SERIAL NUMBER 09/669,159	FILING DATE 09/25/2000 RULE -	CLASS 438	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. TS2000-143	
APPLICANTS Horng-Wen Chen, Taichung, TAIWAN; Chi-How Wu, Tainan, TAIWAN;					
** CONTINUING DATA ***** 12-00' gag					
** FOREIGN APPLICATIONS ***** 12-00' gag					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 11/07/2000 -					
Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <u>8/29/00</u> 12-00' Examiner's Signature Initials		STATE OR COUNTRY TAIWAN	SHEETS DRAWING 6	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 3
ADDRESS George O Saile 20 McIntosh Drive Poughkeepsie, NY 12603					
TITLE In-situ strip process for polysilicon etching in deep sub-micron technology					
FILING FEE RECEIVED 690	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		